

2879



In re Application of:

Docket No. 03500.014023.

TAMAKI KOBAYASHI ET AL.

Examiner: A. Patel

Application No.: 09/440,535

Group Art Unit: 2879

Filed: November 16, 1999

For: SUBSTRATE FOR ELECTRON SOURCE,  
ELECTRON SOURCE AND IMAGE FORMING  
APPARATUS, AND MANUFACTURING METHOD  
THEREOF

Date: May 14, 2002

THE COMMISSIONER FOR PATENTS  
Washington, D.C. 20231

Sir:

Transmitted herewith is an amendment in the above-identified application.

☒ No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	* 113	MINUS	** 138	0	x \$9 \$18	0
INDEP. CLAIMS	* 2	MINUS	*** 3	0	x \$42 \$84	0
Fee for Multiple Dependent claims \$140°/\$280						0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						0

- \* If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.  
 \*\* If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.  
 \*\*\* If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.

RECEIVED  
MAY 23 2002  
TC 2800 MAIL ROOM

☐ A check in the amount of \$\_\_\_\_\_ is enclosed.

☐ Charge \$\_\_\_\_\_ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.

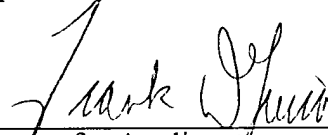
☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.

☐ A check in the amount of \$\_\_\_\_\_ to cover the fee for a \_\_\_\_\_ month extension is enclosed.

☐ A check in the amount of \$\_\_\_\_\_ to cover the Information Disclosure Statement fee is enclosed.

☒ Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicants

Registration No. 42,476

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200



03500.014023

*Amot*  
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TAMAKI KOBAYASHI ET AL.

Application No.: 09/440,535

Filed: November 16, 1999

For: SUBSTRATE FOR ELECTRON  
SOURCE, ELECTRON SOURCE  
AND IMAGE FORMING APPARA-  
TUS, AND MANUFACTURING  
METHOD THEREOF

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:  
) Examiner: A. Patel

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:  
) Group Art Unit: 2879

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:  
) May 14, 2002

Commissioner For Patents  
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the Office Action of February 14, 2002, please amend the  
above-identified application as follows:

I hereby certify that this correspondence is being deposited with the  
United States Postal Service as first-class mail in an envelope  
addressed to: Commissioner for Patents, Washington, D.C. 20231  
on May 14, 2002.

(Date of Deposit)

FRANK A. DeLUCIA

(Name of Attorney for Applicant)

*Frank DeLucia*  
Signature

May 14, 2002

Date of Signature

- Non-elected species claims  
cancelled  
- Non-elected group claims  
cancelled